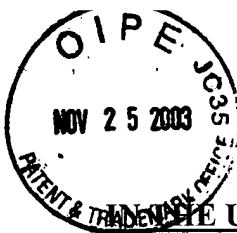


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UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Hiroyuki YANO et al.  
Serial No. : 09/870,085 ✓  
Filed : May 30, 2001  
For : **MANUFACTURING METHOD OF SEMICONDUCTOR  
DEVICE**  
Examiner : Thanhha Pham  
Group Art Unit : 2813

745 Fifth Avenue  
New York, New York 10151

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Date of Deposit: November 25, 2003

I hereby certify that this paper or fee is being deposited with the United States Postal Service "Express Mail Post Office to Addressee" Service under 37 CFR 1.10 on the date indicated above and is addressed to: **Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.**

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COMMUNICATION

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

As noted in the Preliminary Amendment filed on August 25, 2003,  
attached is a Declaration under 37 C.F.R. §1.132 supporting the drawing correction  
submitted with the Amendment.

Applicants submit that the application is now in condition for allowance,  
which action is earnestly solicited.

If any issues remain, or if the Examiner has any further suggestions,  
he/she is invited to call the undersigned at the telephone number provided below.

The Examiner is hereby authorized to charge any insufficient fees or credit  
any overpayment associated with the above-identified application to Deposit Account  
No. 50-0320.

The Examiner's consideration of this matter is gratefully acknowledged.

Respectfully submitted,  
FROMMER LAWRENCE & HAUG LLP

By: 

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